

10/574073

SHIGA7.047APC

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

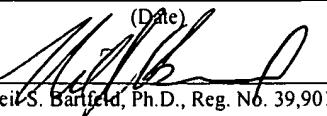
Applicant : Watanabe et al.  
Appl. No. : U.S. National Phase of  
PCT/JP2004/015503  
Filed : Herewith  
For : RESIST COMPOSITION FOR  
ELECTRON BEAM OR EUV  
Examiner : Unassigned  
Group Art Unit : Unknown

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

March 30, 2006

(Date)

  
Neil S. Barfield, Ph.D., Reg. No. 39,901

PRELIMINARY AMENDMENT

**Mail Stop PCT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Prior to examination of the above-referenced application, please enter the following amendments:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks** begin on page 5 of this paper.